

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#13
2/20/03

In re application of

Kiyoshi TAKEI, et al.

Appln. No. 09/482,099

Confirmation No.: Unknown

Filed: January 13, 2000

Group Art Unit: 2877

Examiner: Delma R. Flores Ruiz

RECEIVED
FEB 13 2003
TECHNOLOGY CENTER 2800

For: DISTRIBUTED FEEDBACK TYPE SEMICONDUCTOR LASER DEVICE (As Amended)

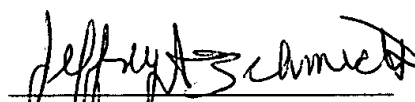
REQUEST FOR APPROVAL OF PROPOSED DRAWING CORRECTIONS

Commissioner for Patents
Washington, D.C. 20231

Sir:

Submitted herewith please find 2 sheets of proposed drawing corrections with the changes indicated in red ink, or are otherwise highlighted. The Examiner is respectfully requested to acknowledge receipt of the drawing corrections and approve the changes.

Respectfully submitted,


Jeffrey A. Schmidt
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Date: February 11, 2003

Accepted by
Examiner
2/20/03